



PATENT APPLICATION

IN AT

RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2823

Application No.:

09/857,803

Examiner:

M. Estrada

Filed: June 11, 2001

Docket No.:

109725

For:

METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

AMENDMENT IN RESPONSE TO EX PARTE QUAYLE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the July 27, 2004 Ex Parte Quayle Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.